

Electronic Patent Application Fee Transmittal

Application Number:	10671922			
Filing Date:	24-Sep-2003			
Title of Invention:	Atomic layer deposition methods, and methods of forming materials over semiconductor substrates			
First Named Inventor/Applicant Name:	Garo J. Derderian			
Filer:	Jennifer J. Taylor/Jaime White			
Attorney Docket Number:	MI22-2296			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
Total in USD (\$)				180